The Consortium for Enabling Technologies and Innovation

Virtual Summer Meeting for Young Researchers

Carbon Nanotubes as an Ionizing Radiation Sensor

Arith Rajapakse

Georgia Institute of Technology

July 7, 2020





Bio



Arith Rajapakse is a 3rd year PhD student researching the use of nanomaterials for radiation detection under Dr. Anna Erickson.

Before coming to Georgia Tech, he earned his B.S in physics from UC Irvine and his M.S. in physics from Cal State Long Beach. His previous research focused on the synthesis of carbon nanotubes (CNTs) and the fabrication of CNT based transistors.







Outline

- Motivation and Background
- Device Features
- Fabrication
- Operation
- Current Work
- Future Work





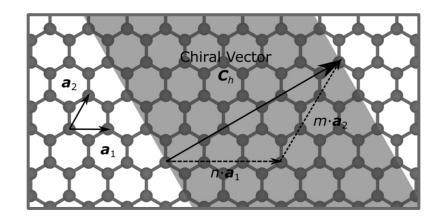


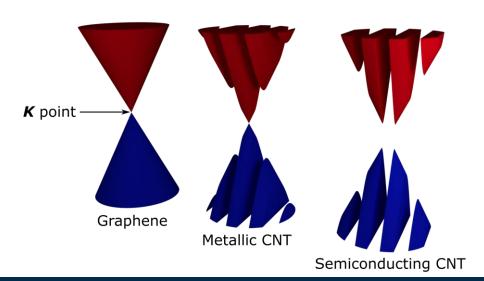
Carbon Nanotubes

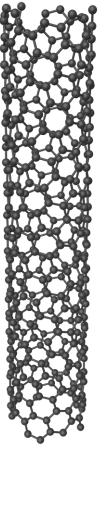
- "Possible successor to silicon"
- Nanostructured material
 - Sheet of graphene rolled into a cylinder
 - Semiconducting or metallic based diameter and chirality

$$d = \frac{a_0}{\pi} \sqrt{n^2 + m^2 + nm}$$

- if n = m, then the CNT is metallic
- if n m is a multiple of 3 and n ≠ m and nm 6= 0, then the CNT is quasi-metallic with a small band gap
- otherwise the CNT is semiconducting
- Semiconducting CNTs are sensitive to external electric fields
 - Changes Fermi Energy E_F and therefore DOS
 - Also modifies Schottky barrier in FETs







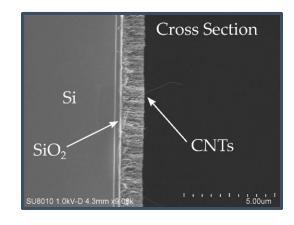


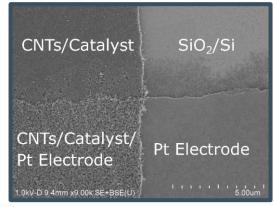


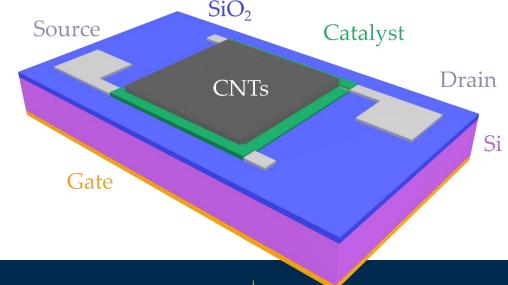


VACNT-based detector features:

- Vertically aligned CNTs as the device channel
- Allows for 3D device geometries
- Grown using Aixtron Black Magic PECVD
- CNTs contacted by source and drain electrodes
 - Platinum
- Gate electrode separated from CNTs by thermal oxide
 - Platinum + 500 micron thick Si + 250 nm oxide
- Charge carriers generated in substrate and sensed by CNTs
- Standard back-gated FET geometry (for now)







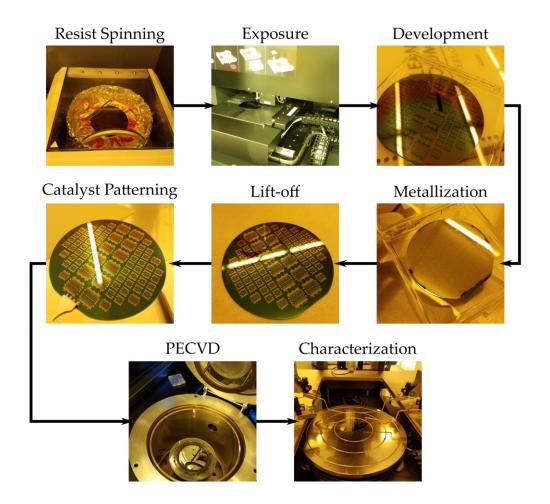


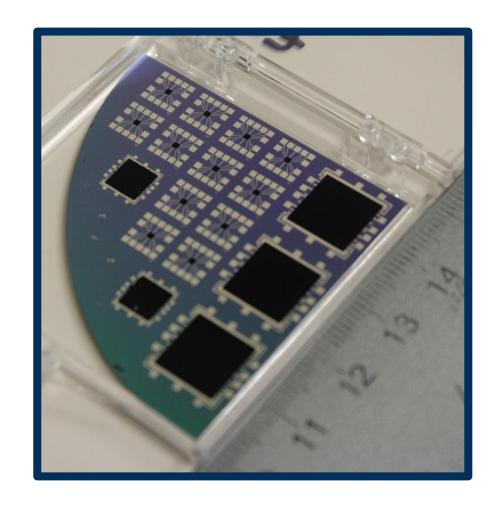




arajapakse@gatech.edu

Fabrication







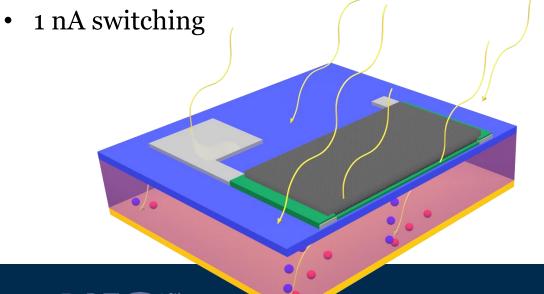


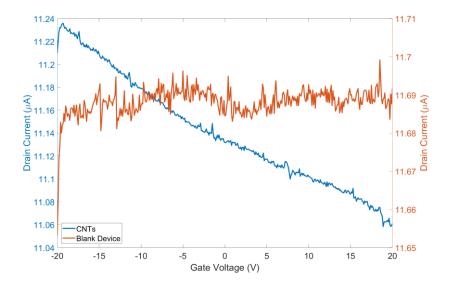


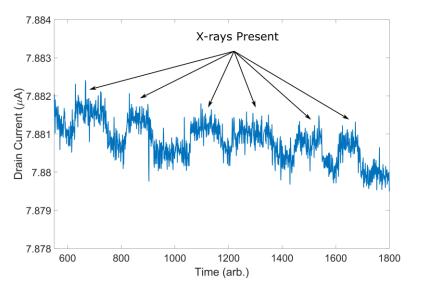
Detector Operation

- Weak p-type FET behavior
 - Conductance increases at positive gate bias (increased tunneling probability of holes)
 - Metallic CNTs allow current flow while semiconducting CNTs are turned off

• Weak device response to ionizing radiation (108 kVp bremsstrahlung x-rays)



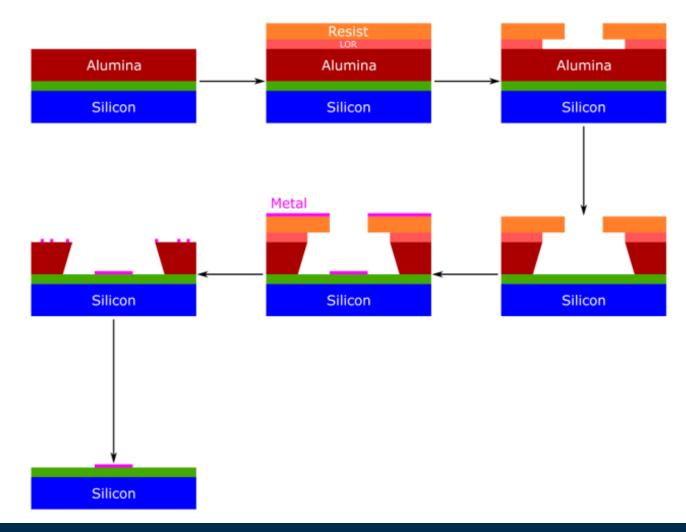






Device Fabrication Overhaul

- Device Leakage
 - Metal redepositing from lift-off process
 - Compounded with high CVD temperature of 900°C
- Sacrificial oxide + bilayer resist to remove contaminants

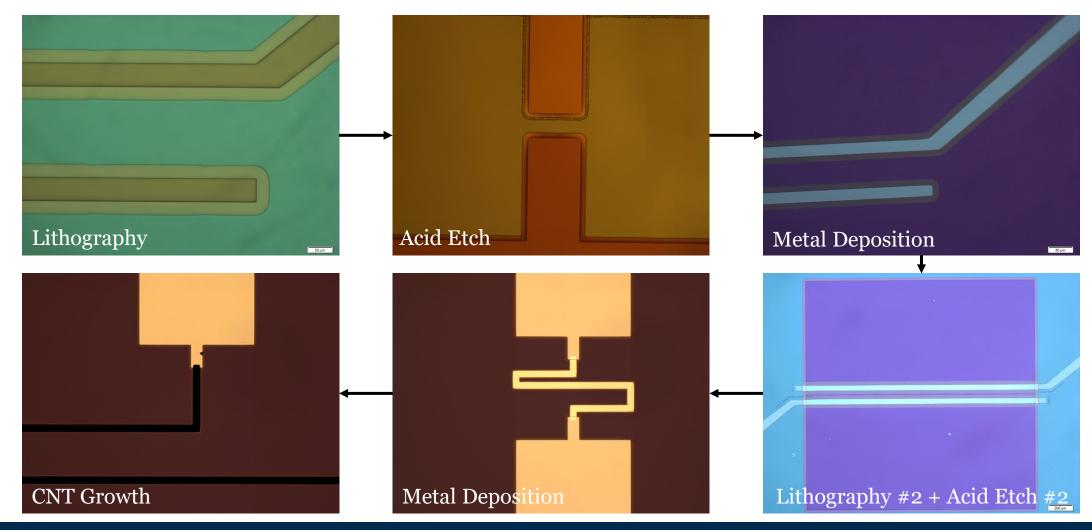








Device Fabrication Overhaul

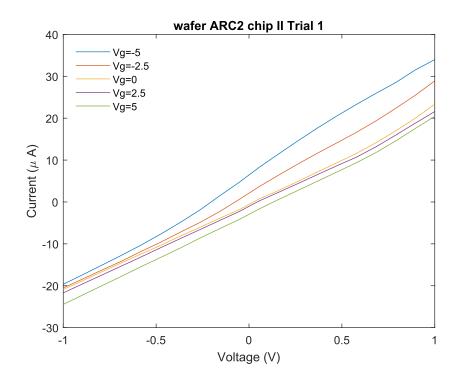


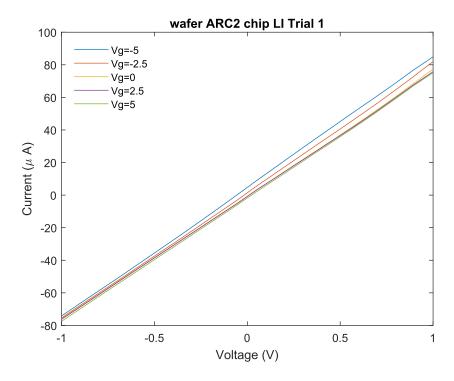


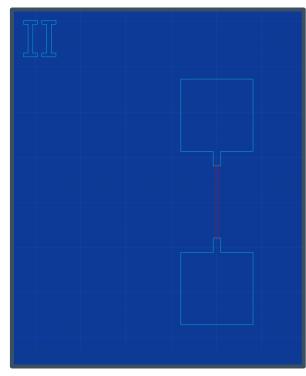




New Device Design







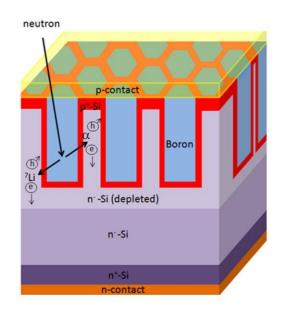


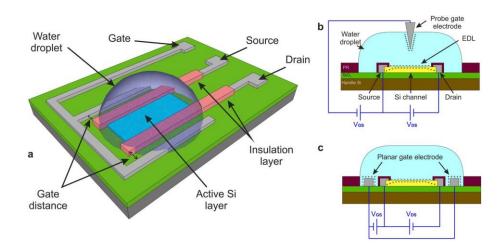




Future Work

- Optimize CNT growth
- Test fabrication process for 3D geometry
- Test device changes to allow for neutron detection (thermal and fast)
- Introduction of boron nitride into fabrication (thermal)







































































Acknowledgement

This material is based upon work supported by the

Department of Energy/National Nuclear Security

Administration under Award Number DE-NA0003921.